

REPLY UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER 1700
Docket No. 1670.1020

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Koji Shigemura

Application No. 10/717,571

Group Art Unit: 1762

Confirmation No. 9396

Filed: November 21, 2003

Examiner: James Lin

For: DEPOSITION MASK FRAME ASSEMBLY, METHOD OF FABRICATING THE SAME,
AND METHOD OF FABRICATING ORGANIC ELECTROLUMINESCENT DEVICE
USING THE DEPOSITION MASK FRAME ASSEMBLY

REQUEST FOR RECONSIDERATION AFTER FINAL REJECTION

Mail Stop AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is in response to the Final Office Action mailed February 27, 2007, and having a period for response set to expire on May 27, 2007.

The following amendments and remarks are respectfully submitted. Entry of this Amendment After Final Rejection and reconsideration of the claims is respectfully requested.

A listing of the claims begins on page 2 of this paper. No claims have been amended.

Remarks begin on page 6 of this paper.